In re Appln. of Takayuki HISAKA Application No. Unassigned

ABSTRACT AMENDMENTS

Replace the Abstract with:

A semiconductor device includes a semiconductor substrate $\frac{10}{10}$, a channel layer $\frac{2}{10}$, a Schottky layer $\frac{5}{20}$, $\frac{5}{20}$, a first layer $\frac{12}{10}$ having a narrower band gap than the Schottky layer, a second layer $\frac{11}{10}$ having band discontinuity with the Schottky layer, a gate electrode $\frac{1}{10}$, $\frac{1}{10}$ n n + layer $\frac{1}{10}$, a source electrode $\frac{1}{2}$, and a drain electrode $\frac{1}{2}$. The first and second layers are $\frac{1}{10}$ in within the Schottky layer, and the second layer is disposed on the first layer.